
**Optics and photonics — Lasers
and laser-related equipment —
Measurement of phase retardation of
optical components for polarized laser
radiation**

*Optique et photonique — Lasers et équipements associés aux lasers
— Mesurage du retard de phase des composants optiques pour le
rayonnement laser polarisé*

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see www.iso.org/directives).

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For an explanation of the voluntary nature of standards, the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the World Trade Organization (WTO) principles in the Technical Barriers to Trade (TBT), see www.iso.org/iso/foreword.html.

This document was prepared by Technical Committee ISO/TC 172, *Optics and Photonics*, Subcommittee SC 9, *Laser and electro-optical systems*, in collaboration with the European Committee for Standardization (CEN) Technical Committee CEN/TC 123, *Lasers and photonics*, in accordance with the agreement on technical cooperation between ISO and CEN (Vienna Agreement).

This second edition cancels and replaces the first edition (ISO 24013:2006), which has been technically revised.

The main changes are as follows:

- [6.3.3](#) was amended to add an additional step requiring that a transmitting optic be aligned so that its optical axis is horizontal;
- [Clauses 2](#) and [6.1](#) were amended to reflect that ISO 14644-1:1999 does not need the year;
- [6.3.1](#), ($\pi/4 \pm 2$) mrad was changed to $\pi/4$ rad \pm 2 mrad;
- [7.1](#) and [8.1](#) were updated to account for phase retardances close to π .

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at www.iso.org/members.html.

Introduction

Normally it is desirable that the state of polarization be not influenced by the optical components used. For the generation or maintenance of specific states of polarization the influence of optical components on the beam polarization is crucial. For generating circularly polarized radiation from linearly polarized radiation $\pi/2$ phase retarders are used.

This document describes methods to determine the relative phase retardation of optical components with respect to the X- and Y-axes of the polarization and s- and p-polarization, respectively. This document is necessary for optics manufacturers, suppliers and customers of such optics for the determination of the influence of phase retardation of optical components.

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Optics and photonics — Lasers and laser-related equipment — Measurement of phase retardation of optical components for polarized laser radiation

1 Scope

This document specifies test methods for the determination of the linear optical phase retardation of optical components by polarized laser beams.

2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

ISO 11145, *Optics and photonics — Lasers and laser-related equipment — Vocabulary and symbols*

ISO 12005, *Lasers and laser-related equipment — Test methods for laser beam parameters — Polarization*

3 Terms and definitions

For the purposes of this document, the terms and definitions given in ISO 11145 and ISO 12005 apply.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- ISO Online browsing platform: available at <https://www.iso.org/obp>
- IEC Electropedia: available at <https://www.electropedia.org/>

4 Symbols and abbreviated terms

Table 1 — Symbols used and units of measure

Symbol	Term	Unit
p_L	degree of linear polarization	1
ϕ	angle of analyser	rad
a_1	amplitude of electric field in X-direction	V/m
a_2	amplitude of electric field in Y-direction	V/m
a, b	principal axes of the polarization ellipse	V/m
δ	phase difference	rad
$\Delta\delta$	phase retardation	rad
E	electric field vector amplitude	V/m
P	radiant power	W
α_X	absorptance in X-direction	1
α_Y	absorptance in Y-direction	1
ψ	angle of the principle axis of the polarization ellipse	rad

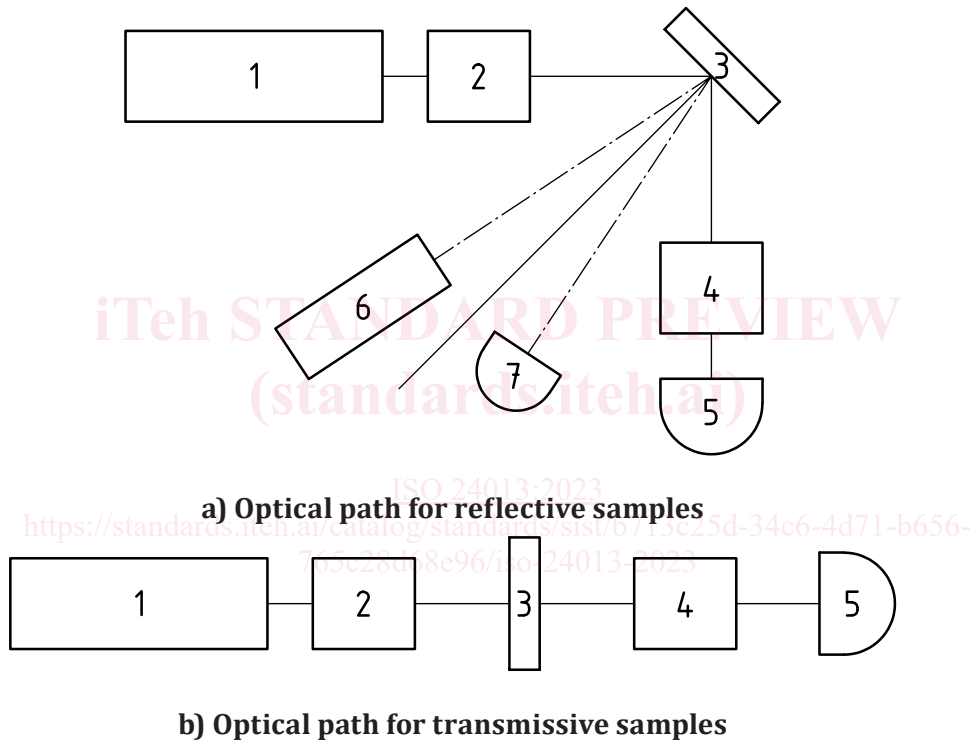
5 Measurement principle

The optical component under test is irradiated by a laser beam with a defined state of polarization. After passing the component the state of polarization of the beam is determined by using an analyser. The phase retardation is then evaluated from the change of the state of polarization.

There are two cases to distinguish:

- a) the expected phase retardation is near zero: in this case a circularly polarized beam shall be used for the test;
- b) the expected phase retardation is near $\pi/2$: in this case a linearly polarized beam shall be used for the test.

Figure 1 shows the measuring set up.



Key

- 1 radiation source
- 2 polarizer (linear or circular)
- 3 sample under test
- 4 analyser
- 5 detector
- 6 alignment laser
- 7 positional sensitive detector

Figure 1 — Schematic drawing of the measuring set up

A laser and a polarizer generating linearly or circularly polarized radiation shall be used in combination with an analyser and a power detector. For measuring reflective samples an alignment laser in combination with a positional sensitive detector ensures a reproducible angle alignment of the sample under test.

6 Preparation of test sample and measuring arrangement

6.1 General

Storage, cleaning and the preparation of the test samples are carried out in accordance with the manufacturer's instructions for normal use.

The environment of the testing place consists of dust-free filtered air with between 40 % and 60 % relative humidity. It is recommended that the residual dust be reduced in accordance with, for example, the clean-room ISO class 7 as specified in ISO 14644-1.

A linearly polarized and monochromatic source, such as a laser, shall be used as the radiation source. To keep errors as low as possible, the beam power stability should be as high as possible.

Wavelength, angle of incidence and state of polarization of the laser radiation used for the measurement shall correspond to the values specified by the manufacturer for the use of the test sample. If ranges are accepted for these three quantities, any combination of wavelength, angle of incidence and state of polarization may be chosen from these ranges.

6.2 Laser beam preparation

The accuracy of the measurement is strongly influenced by a clear definition of the state of polarization of the laser beam. Therefore, it is necessary to prepare the polarization state of the probe beam (linearly or circularly) carefully.

If the expected phase retardation is near $\pi/2$, a linearly polarized beam shall be used. The quantity $(1 - p_L)$, where p_L is the degree of linear polarization, shall be less than 10^{-3} . This shall be verified by using the analyser without the sample in the beam path.

NOTE 1 Such a state of polarization can be achieved by using a linearly polarized laser beam in combination with additional polarizing elements.

If the expected phase retardation is near zero, a circularly polarized beam shall be used. The degree of linear polarization p_L shall be less than 10^{-3} . This shall be verified by using the analyser without the sample in the beam path.

NOTE 2 Such a state of polarization can be achieved by using a linearly polarized laser beam in combination with additional linearly polarizing elements and a $\pi/2$ phase retarding element.

All optical elements shall not increase the quantity $(1 - p_L)$ in the case of a linearly polarized beam and p_L in the case of a circularly polarized beam, by more than 10^{-3} . For this reason, the use of folding mirrors in the test setup is discouraged and all other optical elements shall be used under normal incidence.

6.3 Sample adjustment and system calibration

6.3.1 Reflective samples

The sample shall be mounted very accurately at the angle of incidence according to the manufacturer's specification. The deviation from the intended angle of use shall be less than 2 mrad. For this purpose the component shall be mounted on a precision rotary stage. Back reflecting the laser beam into the laser cavity defines the normal incidence.

Additionally, in the case of a linearly polarized probe beam, the angle between the direction of polarization of the incoming laser beam and the plane of incidence shall be $\pi/4$ rad \pm 2 mrad.

6.3.2 Possible alignment procedure

First, the laser beam shall be adjusted so that the beam propagation is parallel to the surface of the optical table. Second, the beam reflected from the sample shall be adjusted so that the propagation of the reflected beam is also parallel to the surface of the optical table for all angles of incidence. Third, in case of a linearly polarized incoming beam, the angle between the direction of polarization and the plane of the optical table shall be adjusted to be $\pi/4$ rad. This can be achieved by adjusting the linear polarizer initially so that the direction of polarization is parallel to the optical table. This can be checked by using a Brewster window, the turning axis of which is perpendicular to the optical table. If under these conditions the reflected minimum power is propagating parallel to the optical table, then turning of the linear polarizer by $\pi/4$ rad finally provides the desired angle of the linearly polarized beam.

When the alignment has been calibrated according to the procedure described above, the correct alignment of the additional samples can be simplified by using an additional laser with high pointing stability and a positional sensitive detector (see [Figure 1](#)). In this case the additional laser beam hits the component under near-normal incidence and the adjustment of the sample under test is performed so that the reflected laser beam hits the positional sensitive detector at the same position.

6.3.3 Transmissive samples

The sample shall be mounted under the angle of incidence according to the manufacturer's specification. The deviation from the intended angle of use shall be less than 2 mrad.

The sample shall be rotated so that its optical axis is horizontal (parallel to the optical table) within 2 mrad. This may be achieved by setting the polarizer so that the direction of polarization is horizontal, setting the analyser to $\pi/2$ rad, and rotating the sample until there is a minimum signal measured by the detector.

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6.4 Detection system

6.4.1 General

The detection system consists of a polarization analyser and a power detector.

6.4.2 Polarization analyser

To determine the state of polarization of the laser beam after passing the test sample a polarization analyser mounted on a rotary stage is necessary.

The analyser shall be capable of characterizing the state of polarization of the laser beam after passing across the additional polarizer with the specified accuracy (see [6.2](#)).

6.4.3 Power detector

To ensure that the entire beam hits the detector area, the detector width should be at least twice the beam diameter.

A high dynamic range of the signal to noise ratio is required for the low noise detector since this directly influences the resolution. Furthermore, the detector characteristics shall be linear over a wide signal range since this directly influences the accuracy of the measurements.

NOTE Silicon detectors for the visible and near infrared spectral range as well as pyroelectric detectors for the infrared spectral range can meet these specifications.

7 Test procedure

7.1 Test procedure for zero or π phase retardation

7.1.1 General

If the expected phase retardation is near zero or π , the polarization of the probe beam shall be circularly polarized. This shall be achieved by using a linearly polarized laser in combination with a quarter-wave plate or similar means. Before the test the state and the degree of this circular polarization shall be measured and recorded. The initial state of polarization is characterized by (see also [Annex A](#)).

$$\cos \delta = \frac{P(45^\circ) - P(135^\circ)}{2\sqrt{P(90^\circ)P(0^\circ)}} \quad (1)$$

where $P \propto E^2$ is the detector signal magnitude.

7.1.2 Simple test procedure for zero absorbance difference

In the case of no absorbance difference, it is sufficient to measure the detector signals at two analyser positions, 45° and 135° . The phase difference is then given by

$$\cos \delta = \frac{P(45^\circ) - P(135^\circ)}{P(45^\circ) + P(135^\circ)} \quad (2)$$

7.1.3 Test procedure for non zero absorbance difference

If there is a difference in the absorbance for the two polarization components it is sufficient to measure the detector signal at four analyser positions, 0° , 45° , 90° and 135° . The phase difference is given by [Formula \(1\)](#).

The relative difference in the absorbance is then given by

$$\frac{P(90^\circ)}{P(0^\circ)} = \left(\frac{a_2}{a_1} \right)^2 \quad \frac{a_2}{a_1} = \sqrt{\frac{1 - a_Y}{1 - a_X}} \quad (3)$$

7.2 Test procedure for $\pi/2$ phase retardation

7.2.1 General

If the expected phase retardation is near $\pi/2$, the polarization of the probe beam shall be linear. Before the test, the state and the degree of this linear polarization shall be measured and recorded. The initial state of polarization is characterized by a curve fit to the function given by [Formula \(A.4\)](#).

7.2.2 Simple test procedure for zero absorbance difference

In the case of no absorbance difference, it is sufficient to measure the detector signals at two analyser positions, 45° and 135° . The phase difference is then given by [Formula \(2\)](#).

7.2.3 Test procedure for non zero absorbance difference

If there is a difference in the absorbance for the two polarization components it is sufficient to measure the detector signal at four analyser positions, 0° , 45° , 90° and 135° . The phase difference is given by [Formula \(1\)](#).

The relative difference in the absorbance is then given by [Formula \(3\)](#).